



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Zhou et al.

Assignee: Vlma Microsystems Corporation

Title: "Deinterlacer Using Both Low Angle And High Angle Spatial Interpolation"

Appl. No.: 10/721,376

Filing Date: November 25, 2003

Examiner: Michael Lee

Art Unit: 2622

Docket No.: VIM-003

October 2, 2006

Mail Stop Amendment
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the outstanding, non-final office action dated June 30, 2006 ("Office Action"), the Applicants respond as follows and request the Examiner to amend the above-identified application as follows.

Amendments to the Specification begin on page 2 of this Amendment.

Amendments to the Claims are reflected in the listing of claims that begins on page 8 of this Amendment.

There are no amendments to the drawings in this Amendment.

The **Remarks** begin on page 13 of this Amendment.